

DOCKET NO: 247814US90CONT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
YASUJI HIRAMATSU, ET AL. : ATTN: APPLICATION DIVISION  
SERIAL NO: NEW CONTINUATION APPLN. :  
(Based on 09/926,464)  
FILED: HERewith :  
FOR: CERAMIC SUBSTRATE FOR A :  
SEMICONDUCTOR :  
PRODUCING/EXAMINING DEVICE

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the above-identified Continuation application of 09/926,464 as follows.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.